

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Härtle et al.
Serial No. : 10/813,530
Filed : March 29, 2004

Art Unit : 2818
Examiner : Chuong A. Luu
Confirmation No: 5329

Title : METHOD FOR FABRICATING A SEMICONDUCTOR COMPONENT BASED
ON A NITRIDE COMPOUND SEMICONDUCTOR

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO ACTION OF AUGUST 23, 2006
AND
STATEMENT OF THE SUBSTANCE OF THE INTERVIEW

In reply to the Office Action of August 23, 2006, applicant submits the following
remarks: